

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Hongyong Zhang	Art Unit :	2814
Serial No. :	09/362,808	Examiner :	Shrinivas H. Rao
Filed :	July 28, 1999	Conf. No. :	7320
Title :	METHOD OF FABRICATING SEMICONDUCTOR DEVICE		

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
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REMARKS ACCOMPANYING RCE

A listing of claims begins on page 2 of this paper.

Remarks/Arguments begin on page 21 of this paper.